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TRANSMITTAL LETTER (General - Patent Pending)				Docket No. OKI.610	
In Re Application Of: Kazuhide Abe					
Application No. 10/760,457	Filing Date January 21, 2004	Examiner I. Soward	Customer No.	Group Art Unit 2822	Confirmation No. 1391
Title: WIRING STRUCTURE OF SEMICONDUCTOR DEVICE AND PRODUCTION METHOD OF THE DEVICE					
<u>COMMISSIONER FOR PATENTS:</u>					
Transmitted herewith is: Response to Restriction Requirement					
in the above identified application.					
<input checked="" type="checkbox"/> No additional fee is required.					
<input type="checkbox"/> A check in the amount of _____ is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. 50-0238 as described below.					
<input type="checkbox"/> Charge the amount of _____					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional fee required.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.					
 _____ Signature			Dated: May 2, 2005		
ANDREW J. TELESZ, JR. REG. NO. 33,581					
VOLENTINE FRANCOS & WHITT, P.L.L.C. 11951 FREEDOM DRIVE, SUITE 1260 RESTON, VA 20190 TEL. NO. (571) 283-0720					
<div style="border-bottom: 1px solid black; height: 1.2em; margin-bottom: 5px;"></div> (Date) <div style="border-bottom: 1px solid black; height: 1.2em; margin-bottom: 5px;"></div> Signature of Person Mailing Correspondence <div style="border-bottom: 1px solid black; height: 1.2em; margin-bottom: 5px;"></div> Typed or Printed Name of Person Mailing Correspondence					
CC:					



OKI.610
Serial No. 10/760,457

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Kazuhide Abe

Group Art Unit: 2822

Serial No.: 10/760,457

Examiner: I. Soward

Filed: January 21, 2004

Conf. No: 1391

FOR: WIRING STRUCTURE OF SEMICONDUCTOR DEVICE AND PRODUCTION
METHOD OF THE DEVICE

RESPONSE TO RESTRICTION REQUIREMENT

U.S. Patent and Trademark Office
Customer Window,
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Date: May 2, 2005

Sir:

In response to the Restriction Requirement dated April 5, 2005, the following election and remarks are respectfully submitted in connection with the above identified application.

Remarks/Arguments begin on page 2 of this paper.